

Table of Contents

Preface

Comparative Study on Grinding Behavior of C-Face and Si-Face in Laser-Sliced 4H-SiC Wafers	
B.X. Li, X. Zhang, Q. Chen, L.L. Che, J.F. Zhang, H.Y. Fan, X.G. Xu, R.K. Wang and X.F. Chen	1
Effects of Processing Passes on Laser-Sliced SiC	
J.F. Zhang, B.X. Li, Q. Chen, L.L. Che, X. Zhang, H.Y. Fan, Y.Y. Jia, J.W. Wang, Y.F. Xue, R.K. Wang and X.F. Chen	9
Feasibility Study of SiC Wafer Reutilization Process through Laser Splitting and Bonding Techniques	
T. Tanaka, K. Akiyoshi, K. Iwanaga, S. Takahashi, H. Watanabe, K. Hamano and A. Furukawa	19
Impacts of Wafer Thinning Process Using Laser Slice Technique on Silicon Carbide Device Characteristics	
K. Akiyoshi, T. Tanaka, S. Takahashi, K. Iwanaga, K. Hamano and A. Furukawa	25
A Study on the Synthesis and Evaluation of Si/SiC Powders for SiC Wafers Fabrication and Si-Based Devices	
M.B. Park, J. Kim, Y. Cho, Y.H. Kim and S.J. Choi	33
Damage-Free Dicing of SiC Substrate Using High-Pressure SF₆ Plasma: The Time Dependence of Processed Groove Profiles	
Y. Matsumura, S. Iden, D. Toh, J. Yamada and Y. Sano	41
Correlation Study of Physical and Optical Total Thickness Variation in 4H-SiC Substrates	
D.M. Lynch, G.L. Keaton, C.A. Lee and A.T. Bean	47
Impact of Ambient Conditions on Oxide Thickness Distribution on 4H-SiC in Thermal Oxidation Furnace	
T. Fidler and P. Schmid	55
Strain Relief of Silicon Carbide Substrates(4H-SiC) by Wet Etching	
N. Bay, A. Rathnakar, X. Gay, W. Engler, R. Hamid, F. Delahaye, O. Whear, V.A. Shah and H. Kuehnlein	63
CMOS-Compatible Pore Nucleation on 4H-SiC Si-Face via Reactive Ion Etching for Homogeneous Electrochemical Etching	
G. Pfusterschmied, M. Kusolitsch, C. Zellner, M. Perazzi, T.Q. Yang and U. Schmid	69
BPD-Free Dicing of Epitaxial SiC Wafers Using Water Jet Guided Laser	
S. Hirano, H. Kim, S. Takahashi, S. Masui, N. Ohtani and K. Abe	77
Study on Electrochemical Assisted Fixed-Abrasive Lapping for Wafer Thinning of Monocrystalline Silicon Carbide Wafer	
C.H. Wu, C.J. Zhang, S.Y. Huang and C.C.A. Chen	83